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Tae-Wan CHO and Seong-Ho KANG

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U.S. PATENT DOCUMENTS

EXAMINER'S INITIALS	*PATENT NO.	*ISSUE DATE	*INVENTOR NAME	CLASS	SUBCLASS	FILING DATE

U.S. PATENT APPLICATION PUBLICATIONS

	*PATENT APPLN. PUB. NO.	*PUB. DATE	*APPLICANT	CLASS	SUBCLASS	

U.S. PATENT APPLICATIONS

	*APPLN. NO.	*FILING DATE	*INVENTOR	CLASS	SUBCLASS	

FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						Yes	No
/RP/	JP 02-148645	06-1990	Japan (Japanese Full Text and English Abstract)			X	
	JP 09-265913	10-1997	Japan (Japanese Full Text and English Abstract)			X	
	JP 09-237580	09-1997	Japan (Japanese Full Text and English Abstract)			X	
	JP 03-190039	08-1991	Japan (Japanese Full Text and English Abstract)			X	
	JP 06-044907	02-1994	Japan (Japanese Full Text and English Abstract)			X	
	JP 63-131436	06-1988	Japan (Japanese Full Text and English Abstract)			X	
	JP 08-250030	09-1996	Japan (Japanese Full Text and English Abstract)			X	
	JP 08-250029	09-1996	Japan (Japanese Full Text and English Abstract)			X	
/RP/	JP 11-288250	10-1999	Japan (Japanese Full Text and English Abstract)			X	

OTHER ART (Including Author, Title, Date, Pertinent Pages, Publisher, Place of Publication, Etc.)

~~Japanese Office Action dated December 18, 2007.~~

Not considered because no English translation was provided.

EXAMINER /Roy Punnoose/

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